



Attorney Docket # 036 US

PATENT APPLICATION

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Jeffrey A. Trogolo et. al.) : Examiner: Bennett, Rachel M.
Application No.: 10/032,370) : Group Art Unit: 1615
Filed: December 21, 2001) :
For: High Aspect Ratio Encapsulated Inorganic) :
Antimicrobial Additive for Controlled Release) :
March 26, 2003

Commissioner for Patents
Washington, D.C: 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

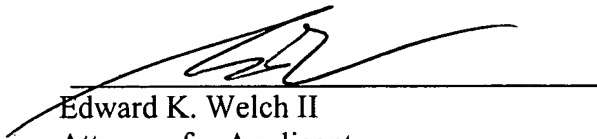
Pursuant to 37 C.F.R. §§ 1.51(b), 1.56, 1.97 and 1.98, Applicants draw the Examiner's attention to the documents that appear listed on the attached Form PTO-1449. Copies of all such documents or, in the case of foreign documents, an English language abstract thereof are attached hereto.

Applicant respectfully requests that each of these documents be considered by the Examiner, made of record herein, listed on the "Notice of References Cited" to be issued in this application and printed on any patent that may issue from this application. Applicant also respectfully requests that a copy of the attached Form PTO-1449, initialed by the Examiner, be returned to Applicants' attorney together with the next communication indicating that these documents have in fact been considered.

This Information Disclosure Statement is being filed before the issuance of an Office Action on the merits and, therefore, no fee is associated with its consideration. Applicant requests a prompt and favorable examination of the instant application.

Applicant's undersigned attorney may be reached by telephone at 781-224-7165, by facsimile at 781-246-3314 or by e-mail at ewelch@agion-tech.com. All paper correspondence should continue to be directed to the address given below.

Respectfully submitted,



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